

Simple solvothermal approach to highly nanostructured hematite thin films

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In this work, we present a solvothermal method for the synthesis of hematite thin films on fluorine-doped tin oxide substrates. This simple method uses a precursor solution of iron(III) 2,4-pentanedionate dissolved in ethanol with a microliter-scale amount of water and yields hematite ~ 500 -nm thick films after annealing. The synthesised films were characterised using an array of methods, including scanning electron microscopy, energy-dispersive X-ray spectroscopy, diffuse reflectance, and powder x-ray diffraction. Incorporating water into the precursor solution provides nucleation sites for the reaction and results show that by altering the amount of water used in the synthesis, it is possible to generate nanocrystalline films of different morphologies, nanocrystal size distributions, and surface areas. This synthetic procedure therefore provides control over the films' physical and electrochemical characteristics. Doping of hematite thin films is also possible using this synthesis, as exemplified by doping with tin by adding tin(II) 2,4-pentanedionate to the precursor solution. To demonstrate utility, we build prototype photoelectrochemical cells using the synthesized hematite as the photoanode.

I. INTRODUCTION

Nanostructured architectures are often desired for applications involving surface-mediated events, such as sensing,^{1–3} energy conversion and storage devices,^{4,5} and catalysis.^{6–8} Several approaches – such as templating^{9,10} or the self-assembly of predefined molecular building blocks^{11,12} – can be taken to achieve materials with high surface areas. Methods capable of directly accessing high-surface nanostructured architectures on a substrate are desirable from scalability, simplicity, and processability points of view. Hematite (α -Fe₂O₃) is attracting attention as a water-splitting photoanode material due to its high natural abundance and low cost, non-toxicity, and stability in aqueous solutions.¹³ One such application of hematite benefiting from such advantages is photoelectrochemical water-splitting.^{14,15} Hematite as a photoanode material possesses intrinsic limitations such as poor electrical conduction. Highly structured α -Fe₂O₃ photoanodes that bring the site of the $e^- - h^+$ pair formation close to the semiconductor-liquid junction can however efficiently allow water to be oxidized.¹³

Nanostructured α -Fe₂O₃ films have been produced by atmospheric-pressure chemical vapor deposition (APCVD).¹⁶ Although APCVD is an effective method to form α -Fe₂O₃ thin films, it requires high reaction temperatures and specialised equipment, making it an expensive procedure to scale up. Other methods for producing nanostructured α -Fe₂O₃ thin films include sputtering,¹⁷ electrodeposition,¹⁸ reactive ballistic deposition,¹⁹ atomic-layer deposition,²⁰ and sol-gel²¹ techniques, all of which require several reaction steps and substantial equipment, again imposing capital cost and practical limitations towards large-scale production.

In this work, inspired by a report from Cai and colleagues²² who synthesised mesocrystalline hematite nanoplates in solution, we present a simple solvothermal method for the preparation of highly structured nanocrystalline hematite thin films on fluorine-doped tin oxide using an ethanol-based solution of iron(III) 2,4-pentanedionate (Fe(acac)₃) as the precursor. Solvothermal synthetic approaches benefit from scalability and simplicity^{23,24} and have been extensively used to form free-standing nanostructures such as nanoparticles and nanorods. However, the application of solvothermal methods to the formation of metal-oxide thin films is still sporadic, with ZnO,²⁵ WO₃,²⁶ BiFeO₃²⁷ being examples, noting that in all of these cases water was used as the solvent (*i.e.* they were *hydrothermal* syntheses). In addition to demonstrating solvothermal α -Fe₂O₃ thin-film formation, we demonstrate size control by varying the amount of water (microliter scale) added to the precursor solution, thereby regulating nucleation and growth, lending greater control over the morphologies of the produced films and an ability to tune the electrochemical properties.

II. METHODS

Materials. All chemicals were used as received from Sigma Aldrich or VWR unless otherwise indicated, without additional purification or modification. Ultrapure water with a resistivity of at least 18 M Ω cm⁻¹ was produced using a Barnstead Ultrapure deionization system and was used for all procedures unless otherwise stated. Fluorine-doped tin oxide (FTO) was purchased from Hartford Glass Company (7 Ω / \square).

Solvothermal synthesis. FTO was chosen as a substrate as this is a fairly robust, transparent material that is also conductive. In general, Fe(acac)₃ (1 mmol) is dissolved in 10.5 mL of absolute ethanol and a variable amount of deionized water and sonicated for 10 minutes. FTO substrates, cut into 3 \times 1 cm rectangles, were cleaned by ten-minute sonication in

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soapy water, deionized water, and isopropanol, in that order, and dried with N_2 gas. These substrates were then subjected to a 15-min ozone plasma treatment to remove any trace organics. The clean, dry FTO substrates were then sealed inside a 25-mL Teflon-lined autoclave with the ethanol-based precursor solution and then heated to 180 °C, for a given amount of time, 24 hours being the optimal reaction time. After naturally cooling to room temperature, the autoclave was opened, and the coated substrates were annealed in a tube furnace in air at 700 °C for 30 minutes.

Sn Doping. Tin-doped hematite films were prepared using the same synthetic procedures as described above, while using $Sn(acac)_2$ as a co-precursor. Amounts ranging from 1-9 atomic percent (expressed herein as Sn / Fe molar ratios) were added to the precursor solution (Table S1). While samples were prepared with and without the presence of added water, presented samples were synthesized in the absence of any water. The autoclaves were heated to 180 °C for periods ranging from 1 to 24 hours, with 6 hours being the optimal time. Coated substrates were annealed in a tube furnace in air at 700 °C for 30 minutes.

Electrochemistry. A CH Instrument Workstation 660D potentiostat was used for all electrochemical measurements. A Pt counterelectrode and a Ag/AgCl (saturated KCl) reference electrode were used. All measurements were done in 0.1 M NaOH supporting electrolyte (pH = 13). Electrochemical measurements were also made using anodic sweeps in order to assess the photoresponse of the hematite thin films (sweep rate is 100 mV s⁻¹ unless stated otherwise). Performing multiple sweeps also allowed for the assessment of the durability of these films under applied voltage.

Electrochemical measurements under simulated solar radiation were made using a Newport solar simulator (150-W Xe arc lamp filtered through an AM 1.5 G air-mass filter) whose power output was measured to 1 Sun (1.5 AM, 100 mW/cm²) using a certified Si reference cell. The setup was equipped with a shutter, allowing for measurements to be made with switching between light and dark during chronoamperometric measurements, holding the applied voltage constant. For these measurements, a total time of 180 seconds was used, with switching between light and dark every 20 seconds.

All electrochemical measurements were performed three times: once in darkness, once with the light hitting the film directly (front illumination) and once with the light hitting the non-coated side of the FTO (backside illumination). All potentials are reported against the reversible hydrogen electrode:

$$E_{RHE} = E_{Ag/AgCl} + 0.059 \text{ V} \times \text{pH} + E_{Ag/AgCl}^{\circ}$$

SEM imaging and EDXS measurements. Scanning electron microscopy (SEM) was performed with a Zeiss SigmaVP field-emission SEM equipped with an Oxford INCA energy-dispersive x-ray spectroscopy (EDXS) unit. Particle sizes within the films were evaluated using the ImageJ software,²⁸ with 300 particles being sized in each sample image. To obtain cross-section images, the FTO substrates coated with $\alpha\text{-Fe}_2\text{O}_3$ were cleaved in two and the freshly broken edges were imaged.

Diffuse reflectance measurements. Diffuse reflectance

spectra were acquired using a Varian Cary 5000 UV-visible spectrophotometer equipped with a diffuse reflectance accessory (DRA-2500). Details of how this data was analysed can be found in the Supporting Information.

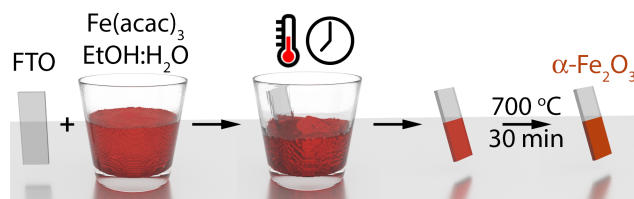
PXRD measurements. Powder x-ray diffraction measurements were made using a Rigaku Miniflex II bench-top diffractometer equipped with a Cu K α x-ray source ($\lambda = 1.5406 \text{ \AA}$). Patterns were acquired at a rate of 0.02 °/min.

Orange II azo-dye experiment. To assess the real surface areas of the synthesized photoanodes, we adapted Grätzel's orange azo-dye experiment.¹⁶ Briefly, the photoanode is soaked in a 1.5-mM solution of Orange II dye (in H₂O, pH adjusted to 3.5 using HCl) for 15 minutes. After 15 minutes, the films are rinsed with dilute HCl (pH = 3.5) to remove any unbound dye molecules. The dye adsorbed to the surface is then desorbed with 0.5 mL 1.0 M NaOH and the optical density at 450 nm measured using UV-visible spectroscopy ($\epsilon_{450\text{nm}} = 1.3 \times 10^6 \text{ M}^{-1} \text{ m}^{-1}$). A standard curve was prepared (Fig. S10) in order to assess the concentration of dye resulting from soaking each sample. The molecular footprint of each dye molecule is 0.40 nm²; it is assumed a monolayer of dye is formed on the electrode's surface.

III. RESULTS AND DISCUSSIONS

$\alpha\text{-Fe}_2\text{O}_3$ thin film characterization

Nanocrystalline $\alpha\text{-Fe}_2\text{O}_3$ thin films on transparent and conductive fluorine-doped tin oxide (FTO) substrates were synthesized using a solvothermal approach, summarised here in Scheme 1.



Scheme 1. Synthesis of nanostructured $\alpha\text{-Fe}_2\text{O}_3$ thin films on FTO substrates. Ratio of ethanol-to-water, reaction temperature, and reaction times were varied. The intermediate films are annealed in air at 700 °C for 30 minutes to obtain nanostructured $\alpha\text{-Fe}_2\text{O}_3$ thin films. Teflon liner is shown as transparent for clarity.

wherein we experimented with the addition of microliter-scale amounts of water to the $Fe(acac)_3$ / EtOH precursor solution to control nanocrystal size. Various parameters such as $Fe(acac)_3$ concentration, solvothermal reactor temperature (T_{solv}), reaction time (t_{solv}) and annealing conditions (T_{anneal} , t_{anneal}) were optimized. We settled on a reaction time of 24 h at 180 °C followed by annealing for 30 minutes at 700 °C in air, and these are the conditions used in this report unless otherwise stated. Under these conditions, we consistently obtained substrates coated with a uniform hematite film covering exclusively the FTO-coated side (Fig. 1). Visually, films produced with 100 μL H₂O appeared the most opaque

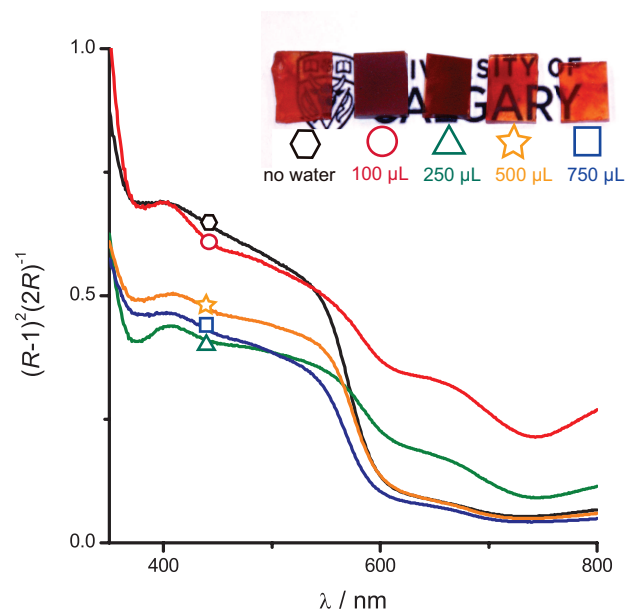


FIG. 1. Kubelka-Munk functions of α -Fe₂O₃ thin films prepared on FTO with varying amounts of water. All samples were prepared under solvothermal conditions at 180 °C for 24 h, followed by a 30-min anneal at 700 °C in air.

and uniform among the series of films synthesized with different volumes of water added, as shown in the inset of Fig. 1. This observation was supported by absorbance measurements, which showed that of the films synthesised with water, the 100 μ L H₂O sample absorbed the most light (Fig. 1). All of these films were found to be stable in aqueous solutions and under applied voltage (*vide infra*). When formed in the absence of water, the resulting films were thin and uneven, and were found to flake off of the substrate during electrochemical testing, demonstrating the importance of even small amounts of water.

Powder x-ray diffraction (PXRD, Fig. 2) was used to identify that after the initial solvothermal reaction, the product mainly consists of hematite, concomitantly with an impurity. Upon annealing at 700 °C in air for 30 minutes, only reflections due to hematite are visible in the powder pattern. Cross-sectional scanning electron microscopy (SEM) revealed that hematite thin films made using this method average *ca.* 535 nm in thickness (Fig. S1) which is desirable for the complete absorption of incoming light.³⁰ EDXS confirmed only iron and oxygen were present within these samples in the expected 2:3 Fe:O ratio, consistent with hematite as the product.

SEM imaging of the films produced using this solvothermal method revealed highly structured and porous materials (Fig. 3). The observed films are reminiscent of hematite photoanodes formed through a solution-based colloidal method.³¹ We find that changing the water concentration significantly affected particle size, with the largest particles (mean diameter = 89 nm) being attributed to the sample synthesized with the least amount of water (100 μ L, *c.f.* Fig. 3). The particle sizes were found to be inversely correlated to the amount of water added, with the smaller mean particle size of 61 nm observed in the sample synthesised with the largest amount of water

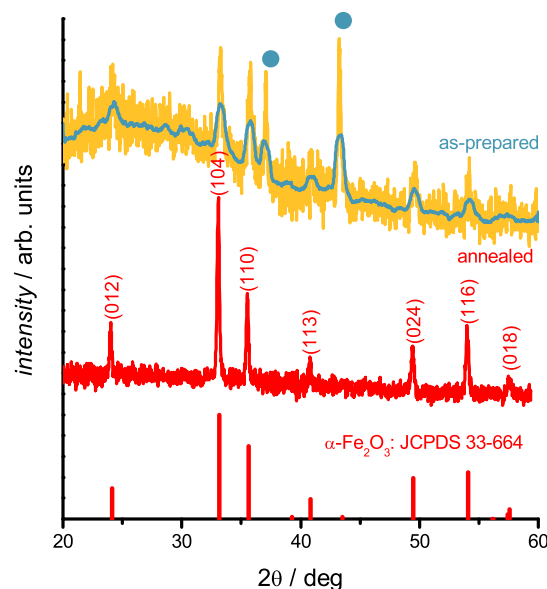


FIG. 2. Powder X-ray diffractogram of obtained thin films on FTO before and after annealing. Blue circles indicate peaks not attributed to hematite, and the line shows smoothed data.

used here, 750 μ L of H₂O. Attempts to form films with 10 μ L and 50 μ L of added water did not produce films on the FTO substrates. As shown in Fig. 3, the size distributions of the films' constituent particles narrows with the volume of water added. These findings lead us to believe that the water participates in the nucleation of hematite nanocrystals by hydrolysing Fe(acac)₃, as was previously proposed by Cai and colleagues, who suggested that an iron hydroxide could constitute the nucleation site during the solvothermal synthesis of α -Fe₂O₃ nanoplatelets.²²

Tin doping

Doping of the thin films was achieved by adding Sn(acac)₂ to the Fe(acac)₃ / EtOH precursor solution in varying proportions. The same synthetic procedures were followed as for the pure hematite films, with 100 μ L of water added to the precursor, as this produced the best pure hematite films. Sn-doped α -Fe₂O₃ films produced using this method were flaky and unstable towards aqueous solutions. This problem was rectified when water was omitted from the precursor solution, leading us to conclude that Sn(acac)₂ is involved in a side reaction with the water, impeding film formation. Upon removing the water from the reaction, the films were uniform, stable in water and showed improved electrochemical results when compared to the pure hematite samples (*vide infra*). Samples of good uniformity and stability were produced after only 6 hours reaction time, allowing us to reduce reaction time from the 24 hours used for the pure hematite films. Further experiments revealed that reaction times under 6 hours were insufficient for film formation. Incorporation of tin into the films

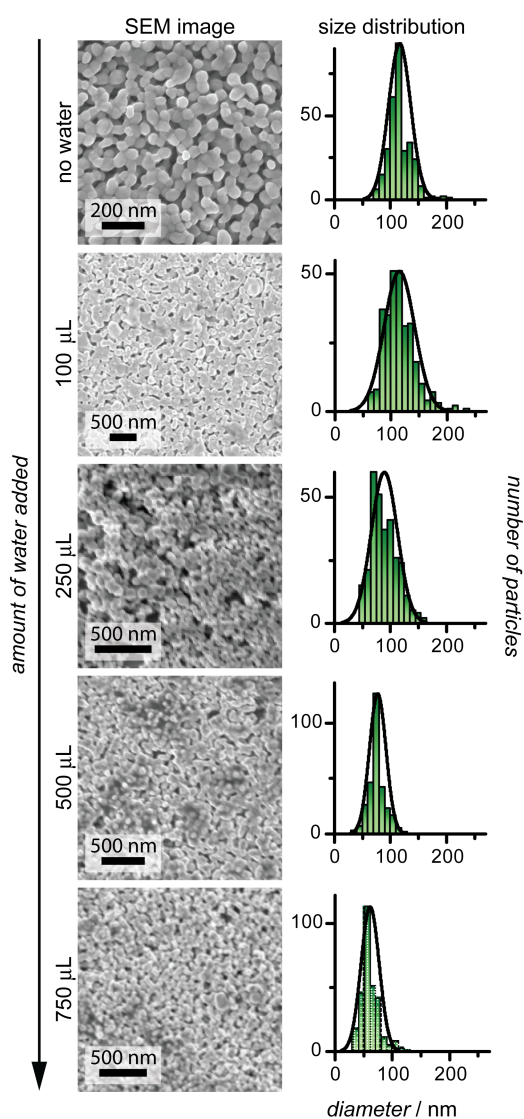


FIG. 3. Representative SEM images and corresponding size distributions for α - Fe_2O_3 samples formed in the presence of various amounts of water. No water: Mean particle diameter = 116 nm, σ = 20 nm. 100 μL H_2O : Mean particle diameter = 115 nm, σ = 27 nm. 250 μL H_2O : Mean particle diameter = 89 nm, σ = 23 nm. 500 μL H_2O : Mean particle diameter = 77 nm, σ = 15 nm. 750 μL H_2O : Mean particle diameter = 61 nm, σ = 15 nm. 300 particles were sized for each sample.

was confirmed by EDXS. Tin observed by EDXS is not attributed to the FTO, as no trace of tin was found when the same method was used to probe samples of pure hematite.

Through SEM imaging, it was observed that the tin-doped series showed a similar trend to the water series in terms of the size distributions, indicating that $\text{Sn}(\text{acac})_2$ also acts as a nucleation promoter for this reaction. The tin-doped samples exhibited much larger particle sizes than the water series samples, as shown in Fig. 5. A larger size is associated with fewer nucleation sites. This is consistent with a larger amount of water (100 μL = 5.5 mmol H_2O) over the 0.08 mmol of $\text{Sn}(\text{acac})_2$ used. The sizes of the particles could likely be fur-

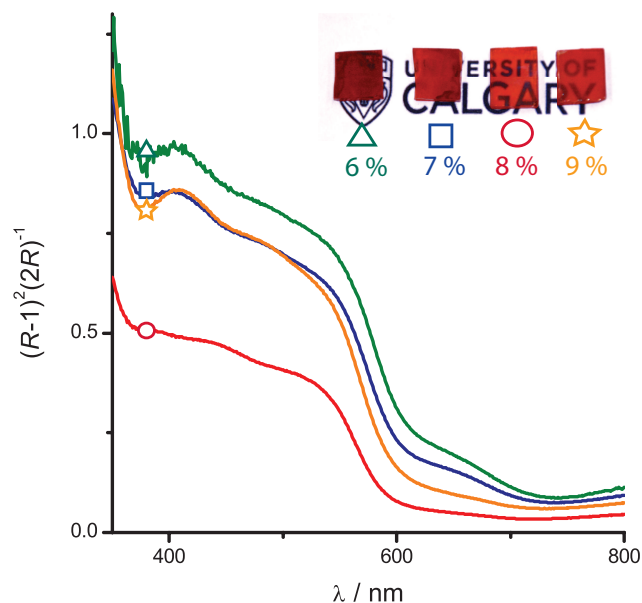


FIG. 4. Kubelka-Munk functions of α - Fe_2O_3 samples prepared on FTO using varying amounts of $\text{Sn}(\text{acac})_2$ in the precursor solution. All samples were prepared using a 6 h reaction at 180 $^\circ\text{C}$, followed by a 30 minute anneal at 700 $^\circ\text{C}$ in air.

ther altered by finely adjusting the amount of tin used, thus allowing for enhanced tuning of the physical characteristics of the resulting films. The morphologies of the Sn-doped α - Fe_2O_3 films also appear to differ from the pure hematite films, with the constituent particles within the films appearing more isolated from one another, in contrast to the fused particles seen in the pure α - Fe_2O_3 samples. The surfaces of the Sn-doped particles also appeared more textured, suggesting a greater surface area.

Optical band gaps of α - Fe_2O_3 and $\text{Sn}:\alpha$ - Fe_2O_3

The band gap of the materials synthesized by this method were investigated using a Tauc analysis of diffuse reflectance spectra (Fig. S2). The details of how the band gap energies were assessed and the associated Tauc plots can be found in the SI (Figs. S3-S4). Typically, hematite exhibits a direct band gap in the range of 1.95-2.35 eV and an indirect band gap of 1.38 - 2.09 eV, meaning that the primary band gap of hematite is an indirect, phonon-assisted band gap.³² The pure hematite samples exhibited a direct band gap of *ca.* 2.07 eV and an indirect band gap of *ca.* 1.73 eV; the Sn-doped samples showed a direct band gap of *ca.* 2.09 eV and indirect band gap of *ca.* 1.80 eV. These band gaps are within the expected ranges for the direct and indirect band gaps of hematite.

Photoelectrochemical water splitting by pristine and doped α - Fe_2O_3 photoanodes

To demonstrate the utility of this simple solvothermal synthetic method, we applied the as-made films – without further

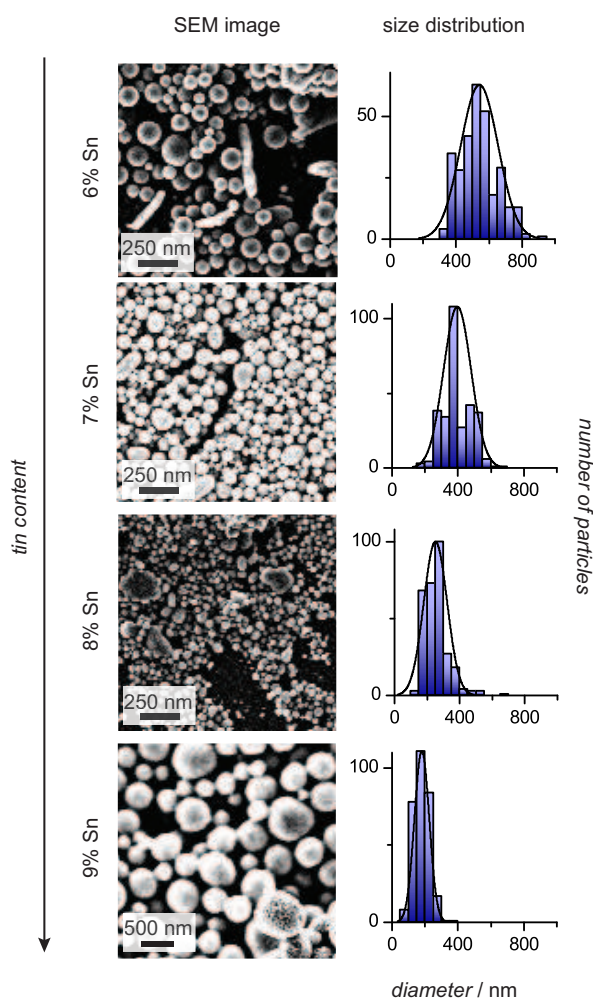


FIG. 5. Representative SEM images and corresponding size distribution data for tin series samples. 6 % Sn: Mean particle diameter = 541 nm, σ = 114 nm. 7 % Sn: Mean particle diameter = 396 nm, σ = 84 nm. 8 % Sn: Mean particle diameter = 251 nm, σ = 72 nm. 9 %: Mean particle diameter = 181 nm, σ = 45 nm. 300 particles were sized for each sample.

optimization – in prototype photoelectrochemical cells. While the results are at this stage modest, they serve as a proof of concept for the method. Further optimization will be the focus of future work.

Electrochemical testing was performed in darkness and under 1-Sun illumination to assess the photoelectrochemical properties of α - Fe_2O_3 thin films and determine how the different film morphologies affect photocatalytic properties. At an applied potential of $E_{\text{RHE}} = 1.5$ V and in the dark, water-splitting is not observed for all electrodes presented here; rather, the onset of the catalytic wave is around 1.6 V vs RHE as seen in anodic scans performed in the dark (Fig. S5). However, upon irradiation a sharp rise in current density, and hence the rate of water oxydation, occurs (Fig. 6); this observation is again corroborated by an anodic current at 1.5 V vs RHE in the presence of light (Fig. S5). Chronoamperometric testing under chopped illumination ($E_{\text{RHE}} = 1.5$ V, 20-s

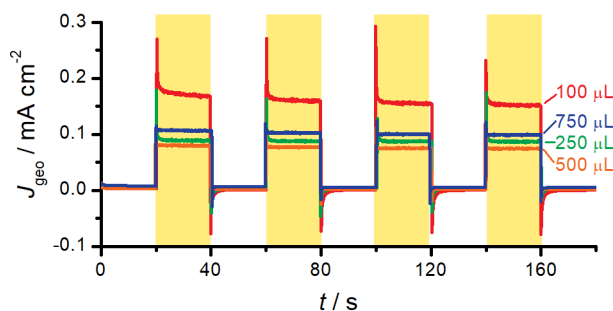


FIG. 6. Chronoamperometry results for samples made with different volumes of water added to the precursor solutions. All measurements were performed at a voltage of 1.5 V versus RHE.

chopping) identifies the sample made with 100 μL H_2O as the most performant among the tested samples, achieving a maximum photocurrent density of 0.18 mA cm^{-2} when irradiated. The sample prepared with 100 μL exhibits the largest individual particles within the films, meaning fewer grain boundaries were likely present in these samples. A lower number of grain boundaries likely enhances the electrical conductivity of these films, however we will discuss below that the increased surface area is likely provides a better explanation for the superior performance of the 100 μL samples compared to the other water series samples.

From Fig. 6, it is clear that these pure hematite films exhibit the typical “spike and overshoot” photocurrent pattern observed in films that display capacitive discharge.³³ This pattern, where a large spike of current is seen immediately upon illumination (the instantaneous photocurrent) and then falls off rapidly, is typical for materials where holes recombine quickly with electrons at the surface. The instantaneous current indicates the separation of electrons and holes, but does not represent charge transfer across the interface.³³ In contrast, the flat portion of the curve that follows represents the steady-state photocurrent, representing the holes that successfully interact with the electrolyte without recombination. Therefore, the ratio of the steady-state over the instantaneous photocurrent is indicative of the efficiency of charge separation in a material.³³ As seen in Fig. 6, pure hematite photoanodes generated using this solvothermal method show a large degree of capacitance. This suggests that a significant amount of recombination occurs before the holes can interact with the water, leading to lower overall efficiency in these systems.

The real surface areas (as opposed to the geometric surface areas used in Fig. 6) of hematite films made in the presence of water were determined by the adsorption of the azo-dye Orange II, which forms a monolayer on nanocrystalline α - Fe_2O_3 .²⁹ The results of these experiments are described in Fig. S6. In essence, the sample prepared with 100 μL of H_2O is found to have the largest real surface area relative to its geometric surface area, with a roughness factor of 23.1 (Fig. S6). This value is comparable to those reported by Grätzel and colleagues for their “cauliflower”-structured hematite thin films prepared by APCVD¹⁶ and equates to approximately four times the real surface of any other sample in the set. This greater surface likely in great part contributes to the over-

all superior performance (per geometric area) of the 100 μL H_2O sample (Fig. 6), as it suggests that the material is highly porous and structured, as is desirable for this application. In fact, when the chronoamperometry data for the pure hematite samples made with different amounts of water was normalized against the true surface areas, the trend in performance of the films was found to be significantly changed, with the 100 μL H_2O sample performing the worst per unit of area, despite that this sample achieved the highest overall current density of all the films made in the presence of water (Fig. S7). While it was argued that fewer grain boundaries were observed in the film prepared with 100 μL of H_2O , the larger crystals make it more likely the photogenerated electron-hole pair will be further from the SCLJ. Films with smaller nanoparticles (*i.e.* more water added) thus present a higher activity based on real surface areas.

Through electrochemical testing, it was also found that backside illumination of the film generated a higher current density than shining the light directly on the coated side of the substrate for every sample tested (pure and doped). In fact, some films that showed no response at all to illumination from the front showed strong current densities when illuminated from the backside, as shown by anodic scans and chronoamperometric measurements (Figs. S5 and S8). This increased activity has been attributed to light being absorbed closer to the conductive FTO when light is directed from the back, meaning electron-hole pairs are generated closer to the conductive substrate. If the electron is excited closer to the substrate, this would lead to better conduction and thus higher efficiency, explaining in part why backside illumination gives superior results. Additionally, diffusion of tin from the FTO substrate into the $\alpha\text{-Fe}_2\text{O}_3$ film during the annealing step is also likely, as has been previously reported.³⁴ This unintentional insertion of tin could lead to better charge separation and enhanced conduction close to the FTO surface, again leading to superior film performance when backside illumination is employed.

The improved photoactivity of $\alpha\text{-Fe}_2\text{O}_3$ films upon Sn-doping was first noted by Sivula *et al.*,³¹ who reported that high sintering temperatures caused diffusion of Sn from the FTO into their hematite photoanode materials. This unintentional doping led to a two-fold increase in film performance and was attributed to an improved absorption coefficient.³¹ Intentional doping of $\alpha\text{-Fe}_2\text{O}_3$ films with tin has shown the same improved performance, as demonstrated by Ling *et al.*,³⁴ who suggested that this improved performance is likely due to increased electrical conductivity from electron-donating Sn. Dunn *et al.* also found that tin doping greatly improved hematite photoanode performance, but this group attributed the improvement to increased hole transfer at the surface, as shown by intensity-modulated photocurrent spectroscopy and chronoamperometry data.³⁵ These findings, as well as tin's low cost and abundance, make tin a promising candidate for the doping of hematite films, as demonstrated here.

Samples prepared with 8% molar ratio of Sn yielded the best chronoamperometry results of all the compositions we attempted, with a photocurrent density of 0.40 mA cm^{-2} (Fig. 7), doubling the best performance observed for the pure

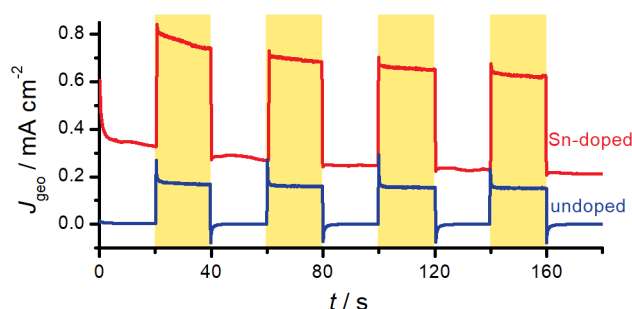


FIG. 7. Chronoamperometry results for sample made with 8% Sn doping (red trace) compared with the best performing pure hematite film (blue trace). All measurements were performed at a voltage of 1.5 V versus RHE under backside illumination.

$\alpha\text{-Fe}_2\text{O}_3$ films. This sample was also the most durable in aqueous solutions and under applied voltage, with no visible deterioration occurring even after several electrochemical tests. The other tin doped samples became blackened during electrochemical testing and flaked off of the FTO substrate (Fig. S9), making it difficult to successfully assess their photoelectrochemical performance. It should also be noted that the chronoamperometry data of Fig. 4 shows a drastically reduced capacitive discharge upon illumination when compared to $\alpha\text{-Fe}_2\text{O}_3$ (Fig. 6), indicating that a smaller degree of surface electron-hole recombination is occurring, supporting the finding of Dunn and colleagues that tin doping might speed up hole transfer kinetics.³⁵

IV. CONCLUSIONS

In summary, the synthetic procedure we have devised here reliably produces hematite thin films with an average thickness of *ca.* 535 nm. By varying the amount of water added to the precursor solution, it is possible to alter the size distribution of the film's particles, meaning that the morphology and resulting electrochemical properties can be tuned. Additionally, the same synthesis can be used to produce tin-doped films by incorporating $\text{Sn}(\text{acac})_2$ into the precursor solution, adding further customisability to these films and a means to further improve their performance. The simplicity and scalability of this procedure makes it an interesting new method for synthesising pure and doped hematite thin films.

SUPPLEMENTARY DATA

The Supplementary Data contains details of Tauc-Lorentz analysis, SEM images, details of surface area determination, and electrochemical characterization.

Acknowledgements

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Electronic Supplementary Information:

Simple solvothermal approach to highly nanostructured hematite thin films

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DIFFUSE REFLECTANCE MEASUREMENTS AND ASSESSMENT OF BAND GAP ENERGIES

Diffuse reflectance measurements were made in order to assess the band gap energies of the materials we synthesized. Hematite has well-defined band gap E_g energies of 1.95-2.35 eV for the direct band gap and 1.38-2.09 for the indirect band gap. Using the Tauc relationship,

$$\alpha h\nu \propto (h\nu - E_g)^n \quad (1)$$

It is possible to determine the band gap energy of a material based on the absorption of light. In this relationship, α denotes the absorption coefficient, $h\nu$ the energy of the photon, and n is an exponent that takes into account the nature of the transition ($n = \frac{1}{2}$ for direct allowed transitions, $n = 2$ for indirect allowed transitions). Usually the absorption can be measured directly using UV-visible spectroscopy, but due to the opaque natures of our films, this was not possible. For this reason, we used diffuse reflectance to obtain the reflectance R of our films, which we converted to transmittance T using the formula:

$$\frac{1}{T} = \frac{(1 - R)^2}{2R} \quad (2)$$

This is then transformed to give α using the relationship:

$$\alpha = -\frac{1}{d} \ln T \quad (3)$$

Where d is the film thickness. Here, we have assumed that all of the films had an average thickness of approximately 535 nm. Once these values are obtained, the Tauc plots can be generated with the photon energy on the x -axis and $(\alpha h\nu)^{\frac{1}{n}}$ on the y -axis. An extrapolation of the longest linear region of the plot gives the value of the band gap as the horizontal axis intercept.

TABLES

Sample	Amount $\text{Sn}(\text{acac})_2$ (g; mmol)	Amount $\text{Fe}(\text{acac})_3$ (g; mmol)
6 %	0.0192; 0.06	0.353; 1.00
7 %	0.0224; 0.07	0.353; 1.00
8 %	0.0256; 0.08	0.353; 1.00
9 %	0.0288; 0.09	0.353; 1.00

TABLE S1. Sn doping compositions

FIGURES

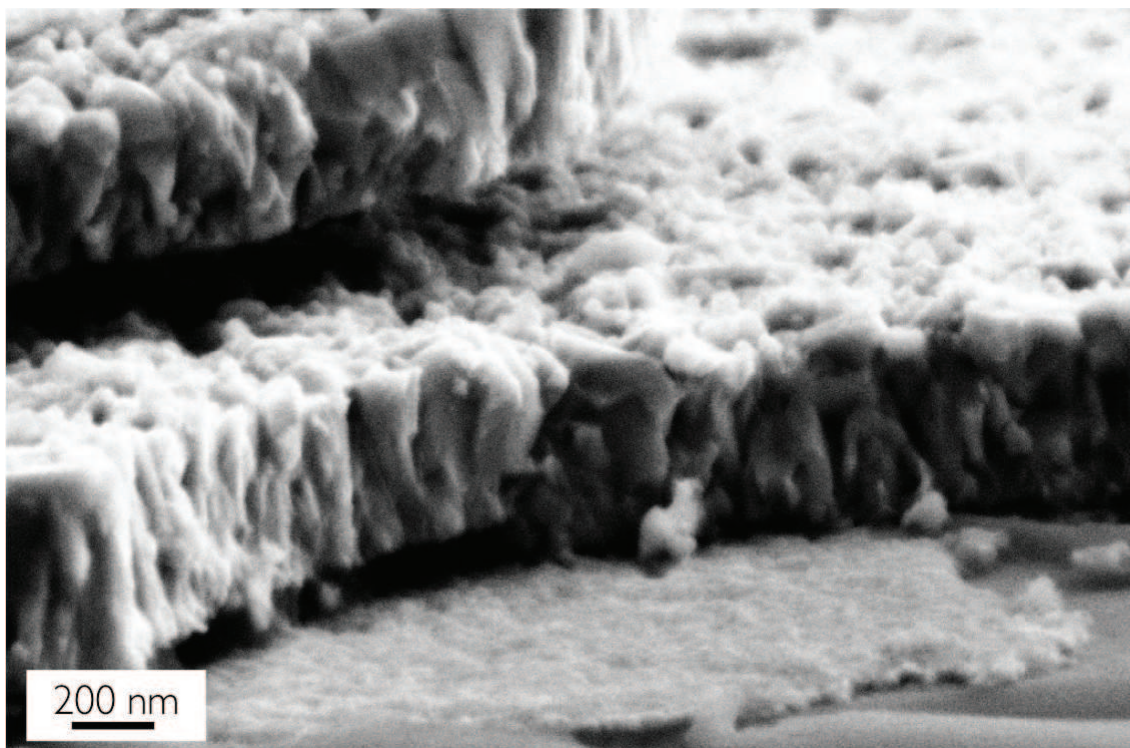


FIG. S1. Cross-sectional SEM image of pure hematite sample synthesized with 100 μL H_2O .

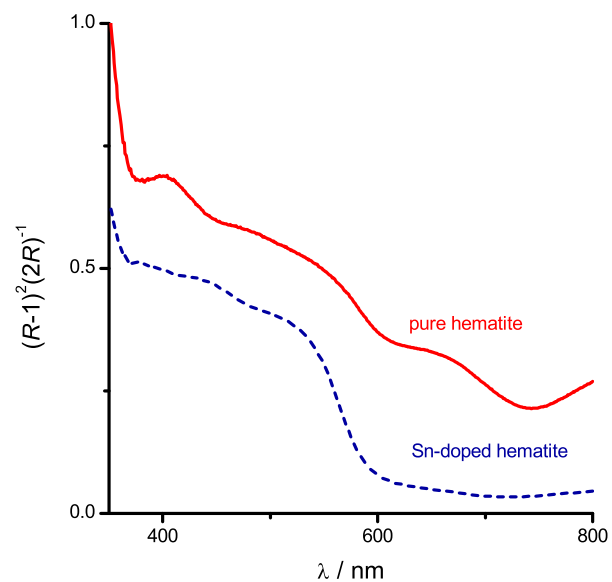


FIG. S2. Kubelka-Munk functions of pure α -Fe₂O₃ thin film and 8% Sn-doped α -Fe₂O₃ film.

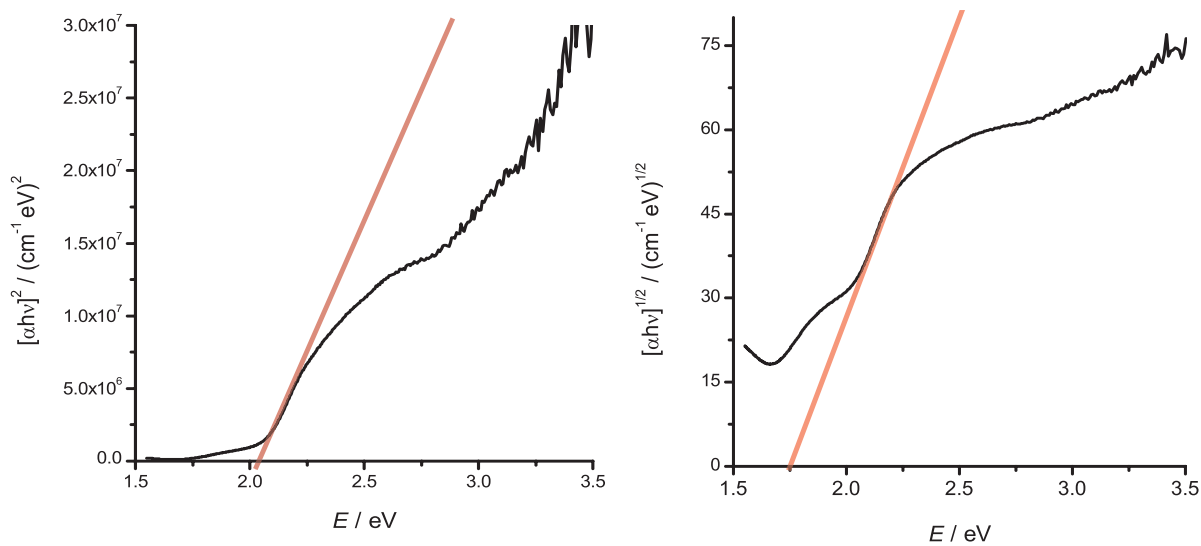


FIG. S3. Tauc plots of direct band gap (left) and indirect band gap (right) for pure hematite sample synthesized with 100 μL H₂O. The direct band gap energy is estimated to be *ca.* 2.04 eV, while the indirect band gap energy is approximately 1.74 eV. These values are within the accepted range for hematite.

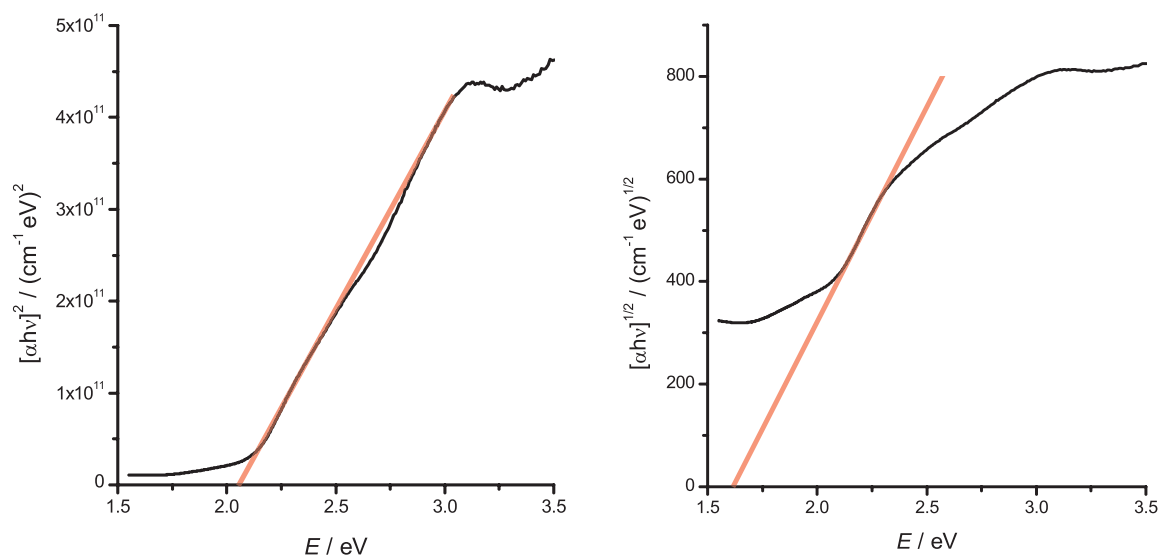


FIG. S4. Tauc plots of direct band gap (left) and indirect band gap (right) for 7% Sn-doped hematite sample. The band gap energies are estimated to be *ca.* 2.04 eV and 1.63 eV for the direct and indirect band gaps, respectively. These values are within the accepted range for hematite.

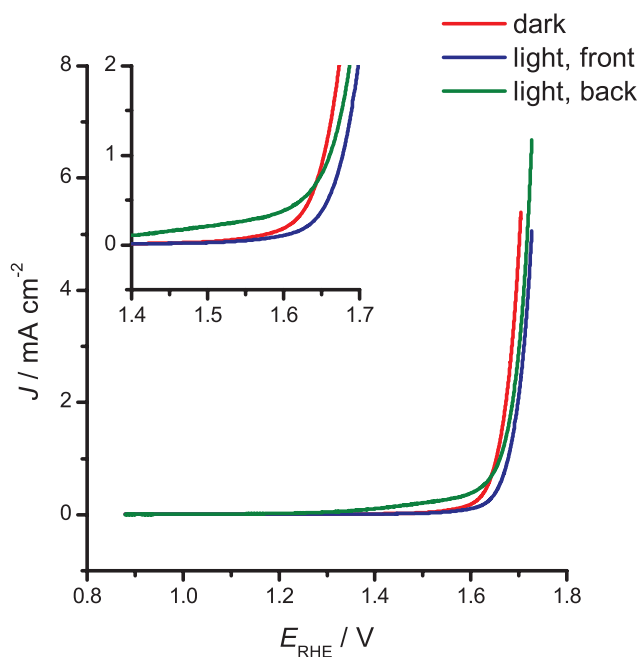


FIG. S5. Anodic scan of pure hematite sample synthesized with 100 μL H_2O . Inset: zoom of onset region, showing enhanced performance with backside illumination.

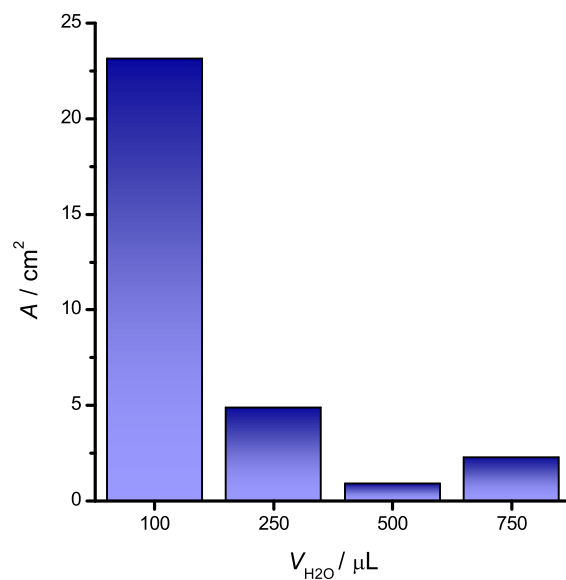


FIG. S6. Real surface area (per 1.0 cm^2 of geometric surface area) for samples prepared with various amounts of water. These values are equivalent to often-reported "roughness factors" of the samples.

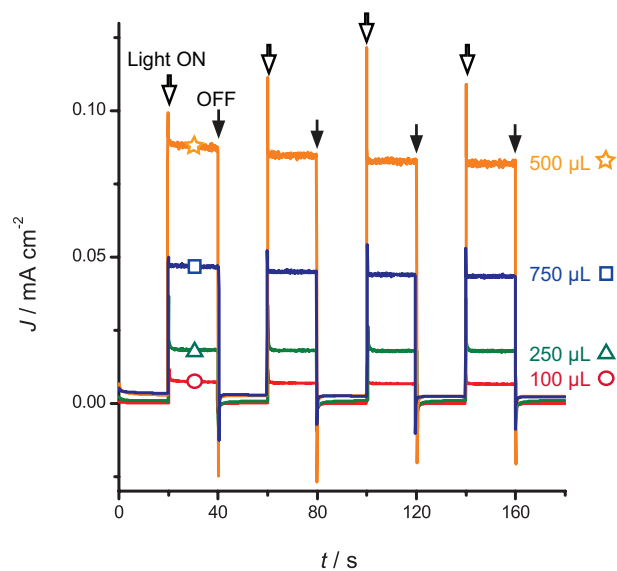


FIG. S7. Chronoamperometry of pure hematite films normalized to their real surface areas as determined by the Orange II azo-dye experiment.

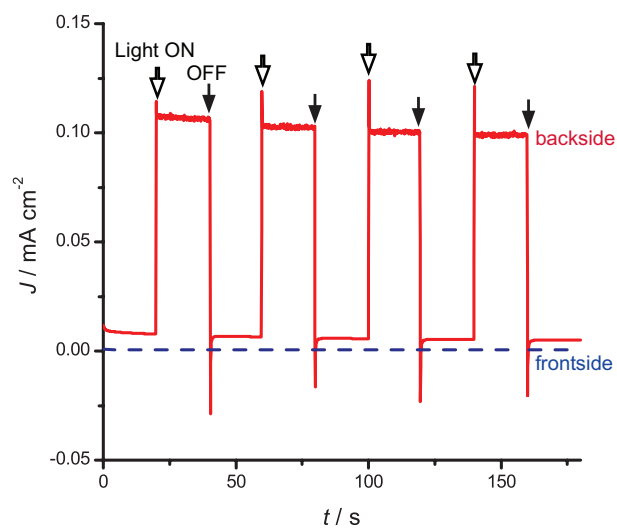


FIG. S8. Chronoamperometry of pure hematite sample synthesized with $750 \mu\text{L H}_2\text{O}$, showing the difference in response between illumination from the front (blue trace) and from the back (red trace).

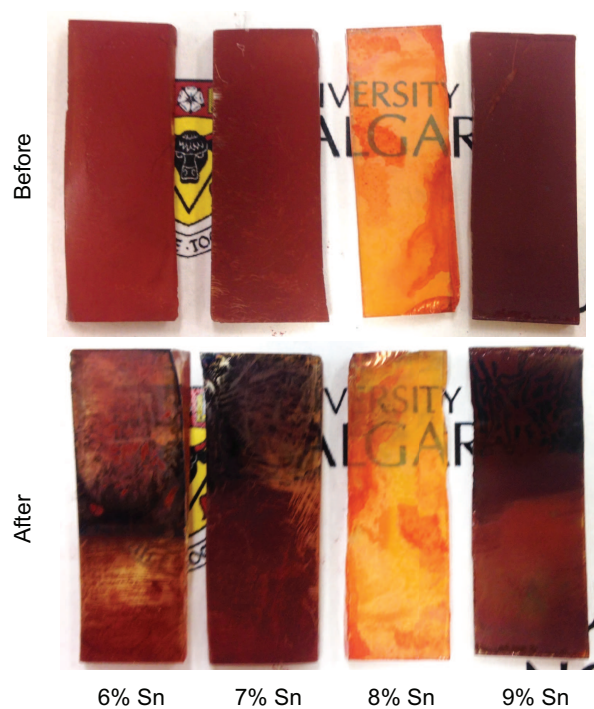


FIG. S9. Photos of Sn-doped hematite films before and after electrochemical testing.

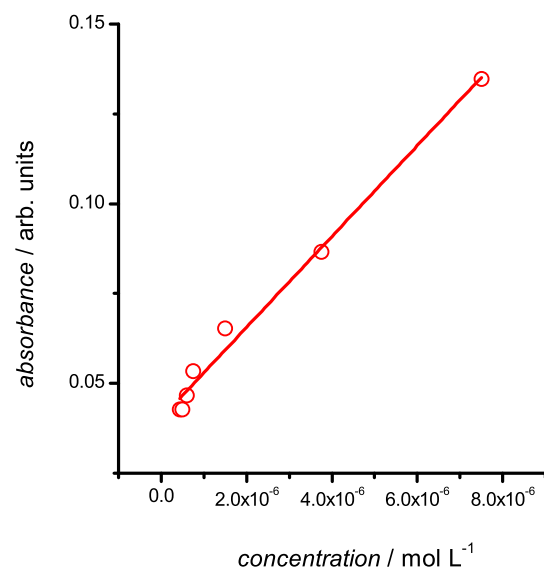


FIG. S10. Standard curve for Orange II azo-dye experiment.